

Docket No. 241315US2CONT

IN RE APPLICATION OF: Eiji SHIDOJI et al.

SERIAL NO: 10/635,816

FILED: August 7, 2003

FOR: SPUTTERING APPARATUS AND SPUTTER FILM DEPOSITION METHOD



IFW

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

- ☐ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	34	MINUS	33	1	x \$18 =	\$18.00
INDEPENDENT	12	MINUS	6	6	x \$88 =	\$528.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS				+ \$300 = \$0.00
		TOTAL OF ABOVE CALCULATIONS				\$546.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment				+ \$40 = \$0.00
		TOTAL				\$546.00

- ☐ A check in the amount of **\$0.00** is attached.
- ☒ Credit card payment form is attached to cover the fees in the amount of **\$546.00**
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

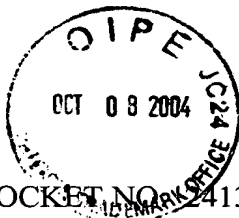
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DOCKET NO. 241315US2CONT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
EIJI SHIDOJI, ET AL. : EXAMINER: VERSTEEG, S. H.
SERIAL NO: 10/635,816 :
FILED: AUGUST 7, 2003 : GROUP ART UNIT: 1753
FOR: SPUTTERING APPARATUS AND SPUTTER FILM DEPOSITION METHOD

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Official Action mailed July 9, 2004, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 18 of this paper.

10/12/2004 CNGUYEN 00000051 10635816

01 FC:1202
02 FC:1201

18.00 OP
528.00 OP